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2881 #3

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JUL 25 2002

Applicant : Hiroyuki Nishimura

Serial No. : 10/076,034

Filed : February 13, 2002

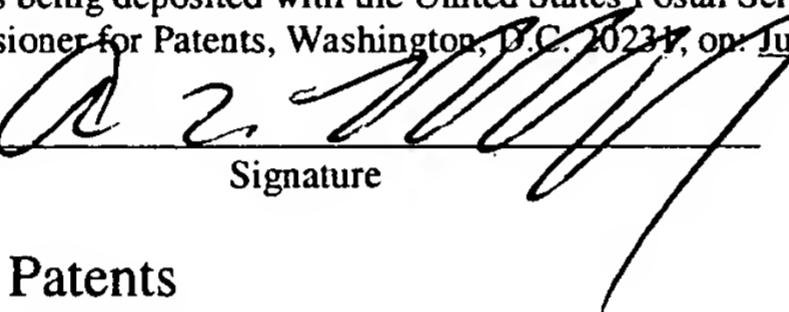
For : METHOD FOR PRODUCING SYNTHETIC QUARTZ  
GLASS MEMBERS FOR EXCIMER LASERS AND  
SYNTHETIC QUARTZ GLASS MEMBERS FOR  
EXCIMER LASER OPTICS PRODUCED BY THE  
SAME

Group art unit : 2881

Examiner : unknown

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on July 15, 2002.

Andrew L. Tiajoloff  
Name of Applicant, Assignee  
or Registered Representative

  
Signature

July 15, 2002  
Date of Signature

Assistant Commissioner for Patents  
Washington, D.C. 20231

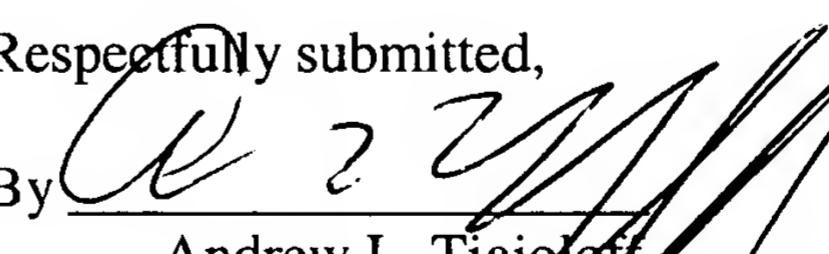
INFORMATION DISCLOSURE STATEMENT

SIR:

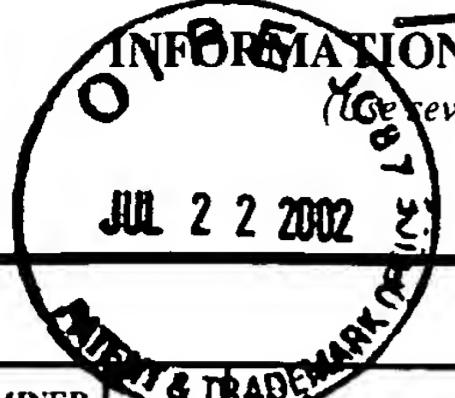
Applicant submits herewith a PTO form 1449, a copy of the listed reference, and a copy of the recent European search report in which the reference was cited. Entry of this reference in the application file and formal allowance are respectfully requested.

It is not believed that any fee is required for consideration of this reference, but if a fee is required, please deduct it from deposit account 501659.

Should any questions arise, the Examiner is invited to telephone attorney for applicant at 212-351-3447.

Respectfully submitted,  
By   
Andrew L. Tiajoloff  
Reg. No. 31575

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New York, New York 10017  
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(Use several sheets if necessary)

JUL 22 2002

**Applicant(s)**

Hiroyuki Nishimura

**Filing Date**

February 13, 2002

Group Art Uni

2881

## **U.S. PATENT DOCUMENTS**

## FOREIGN PATENT DOCUMENTS

**OTHER DOCUMENTS** (*Including Author, Title, Date, Pertinent Pages, Etc.*)

**EXAMINER**

#### DATE CONSIDERED

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.